

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Youhei SAKAI et al.

Serial No: Not assigned

Filed: July 27, 2006

For: Mold, Method of Forming the Same, and  
Method of Producing Polycrystalline  
Silicon Substrate Using the Mold

Art Unit: Not assigned

Examiner: Not assigned

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Prior to the first Office Action in the present application, please enter and consider the following amendments and remarks:

**Amendments** to the specification begin on page 2 of this paper.

**Amendments** to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.